



ELG Docket No. ILL01-010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First
Named

Inventor: David Y. Kim

Serial No.: 10/760,144

Examiner Matthew J. Song

Filing

Date: January 15, 2004

Group Art Unit No. 1722

Title:

PLATFORM AND SYSTEM FOR
CRYSTAL NUCLEATION AND
GROWTH

RESPONSE TO RESTRICTION/ELECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of March 21, 2006, Applicants elect, without traverse, Group I, claims 1-17 and 32-45.

Applicants submit that the present application is now ready for examination on the merits. Early notice of such action is earnestly solicited.

Respectfully submitted,

Paul E. Rauch, Ph.D.,
Registration No. 38,591

Evan Law Group LLC
566 West Adams
Suite 350
Chicago, Illinois 60661
(312) 876-1400



JPW

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**TRANSMITTAL
AND
CERTIFICATE OF MAILING UNDER 37 CFR 1.8**

I certify that the following correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

M.S. – Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

on

April 21, 2006

Date

Paul E. Rauch, Ph.D., Registration No. 38,591

typed or printed name of person signing Certificate

1. Response to Restriction/Election

No Fee Due - - The Commissioner is authorized to charge any required fees **not covered by this credit card payment** or credit any overpayment to Deposit Account Number 50-3123. (A duplicate copy of this sheet is attached.)

**Customer No. 43320
Evan Law Group LLC
566 West Adams
Suite 350
Chicago, Illinois 60661
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